

JAN 21 2005

Attorney's Docket No.: Intel 10559-882001
Client's Ref. No.: P17484**OFFICIAL COMMUNICATION FACSIMILE:****OFFICIAL FAX NO: (703) 872-9306**Number of pages including this page **9**Applicant : Yan Borodovsky
Serial No. : 10/693,373
Filed : October 24, 2003Art Unit : 1756
Examiner : unknown
Assignee : Intel Corporation

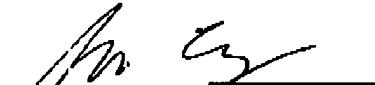
Title : Composite Optical Lithography Method For Patterning Lines Of Unequal Width

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Attached to this facsimile communication cover sheet is an Information Disclosure Statement, faxed this 21st day of January, 2005, to the United States Patent and Trademark Office.

Respectfully submitted,

Date: January 21, 2005



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Attorney's Docket No.: Intel 10559-882001/PJ7484

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yan Borodovsky Art Unit: 1756
Serial No.: 10/693,373 Examiner: unknown
Filed : October 24, 2003 Assignee: Intel Corporation
Title : COMPOSITE OPTICAL LITHOGRAPHY METHOD FOR PATTERNING
LINES OF UNEQUAL WIDTH

VIA FACSIMILE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicants call attention to the attached Information Disclosure Statement and document listed on form PTO-1449.

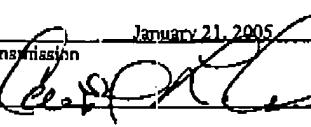
This filing is being made before the receipt of a first Office action on the merits. No fee is required.

The documents are in the English language; hence no concise explanation is necessary per Rule 98(a)(3).

Consideration of the foregoing and enclosures plus the return of a copy of the enclosed form PTO-1449 with the Examiner's initials in the left column per MPEP 609 are earnestly solicited along with an early action on the merits.

CERTIFICATE OF TRANSMISSION BY FACSIMILE

I hereby certify that this correspondence is being transmitted by facsimile to the Patent and Trademark Office on the date indicated below.

Date of Transmission January 21, 2005
Signature 

Carroll Allman
Typed or Printed Name of Person Signing Certificate

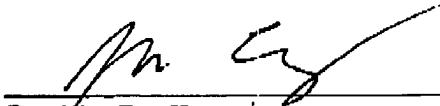
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Attorney's Docket No.: Intel 10559-BI2001
/P:7484

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Respectfully submitted,



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Sheet 1 of 1

Substitute Form PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 10559-882001	Application No. 10/693,373
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Yan Borodovsky		
		Filing Date October 24, 2003	Group Art Unit 1756	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation
							Yes
	AL						
	AM						
	AN						
	AO						
	AP						

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AQ	"Gratings of regular arrays and trim exposures for ultralarge scale integrated circuit phase-shift lithography"; Fritze et al.; Journal Vacuum. Sci Technology B; Vol. 19, No. 6, pp. 1366-2370; Nov/Dec 2001
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Substitute Disclosure Form (PTO-1449)